

Yimo Han

List of Publications by Year in descending order

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56
papers

7,338
citations

212478

28
h-index

232693

48
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57
all docs

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docs citations

57
times ranked

11916
citing authors

#	ARTICLE	IF	CITATIONS
1	Ultrafast Pump-Probe Microscopy on 2D Transition Metal Dichalcogenides. <i>Advanced Photonics Research</i> , 2022, 3, .	1.7	3
2	Efficient conversion of low-concentration nitrate sources into ammonia on a Ru-dispersed Cu nanowire electrocatalyst. <i>Nature Nanotechnology</i> , 2022, 17, 759-767.	15.6	318
3	Direct visualization of floppy two-dimensional DNA origami using cryogenic electron microscopy. <i>IScience</i> , 2022, 25, 104373.	1.9	5
4	Uncovering material deformations via machine learning combined with four-dimensional scanning transmission electron microscopy. <i>Npj Computational Materials</i> , 2022, 8, .	3.5	15
5	Large Single Crystals of Two-Dimensional π -Conjugated Metal-Organic Frameworks via Biphasic Solution-Solid Growth. <i>ACS Central Science</i> , 2021, 7, 104-109.	5.3	40
6	Synthesis of High-Performance Monolayer Molybdenum Disulfide at Low Temperature. <i>Small Methods</i> , 2021, 5, e2000720.	4.6	27
7	Rapid and Semi-Automated Analysis of 4D-STEM data via Unsupervised Learning. <i>Microscopy and Microanalysis</i> , 2021, 27, 58-59.	0.2	3
8	High-yield monolayer graphene grids for near-atomic resolution cryoelectron microscopy. <i>Proceedings of the National Academy of Sciences of the United States of America</i> , 2020, 117, 1009-1014.	3.3	84
9	Uncovering Atomic and Nano-scale Deformations in Two-dimensional Lateral Heterojunctions. <i>Microscopy and Microanalysis</i> , 2020, 26, 1630-1631.	0.2	0
10	Aberration-corrected STEM imaging of 2D materials: Artifacts and practical applications of threefold astigmatism. <i>Science Advances</i> , 2020, 6, .	4.7	13
11	Structure and mechanism of human diacylglycerol O-acyltransferase 1. <i>Nature</i> , 2020, 581, 329-332.	13.7	72
12	Mixed-state electron ptychography enables sub-angstrom resolution imaging with picometer precision at low dose. <i>Nature Communications</i> , 2020, 11, 2994.	5.8	63
13	Imaging Polarity in Two Dimensional Materials by Breaking Friedel's Law. <i>Ultramicroscopy</i> , 2020, 215, 113019.	0.8	20
14	Graphene-assisted spontaneous relaxation towards dislocation-free heteroepitaxy. <i>Nature Nanotechnology</i> , 2020, 15, 272-276.	15.6	71
15	Realization of Quantum Hall Effect in Chemically Synthesized InSe. <i>Advanced Functional Materials</i> , 2019, 29, 1904032.	7.8	23
16	Phase Imaging beyond the Diffraction Limit with Electron Ptychography. <i>Microscopy and Microanalysis</i> , 2019, 25, 6-7.	0.2	1
17	Micromechanical Systems: Atomic Layer Deposition for Membranes, Metamaterials, and Mechanisms (<i>Adv. Mater.</i> 29/2019). <i>Advanced Materials</i> , 2019, 31, 1970212.	11.1	0
18	Scaling-up Atomically Thin Coplanar Semiconductor-Metal Circuitry via Phase Engineered Chemical Assembly. <i>Nano Letters</i> , 2019, 19, 6845-6852.	4.5	46

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19	Atomic Layer Deposition for Membranes, Metamaterials, and Mechanisms. <i>Advanced Materials</i> , 2019, 31, e1901944.	11.1	24
20	2D Materials: Metal-Guided Selective Growth of 2D Materials: Demonstration of a Bottom-Up CMOS Inverter (Adv. Mater. 18/2019). <i>Advanced Materials</i> , 2019, 31, 1970132.	11.1	1
21	Metal-Guided Selective Growth of 2D Materials: Demonstration of a Bottom-Up CMOS Inverter. <i>Advanced Materials</i> , 2019, 31, e1900861.	11.1	36
22	Additive manufacturing of patterned 2D semiconductor through recyclable masked growth. <i>Proceedings of the National Academy of Sciences of the United States of America</i> , 2019, 116, 3437-3442.	3.3	46
23	GaN/NbN epitaxial semiconductor/superconductor heterostructures. <i>Nature</i> , 2018, 555, 183-189.	13.7	116
24	Coherent, atomically thin transition-metal dichalcogenide superlattices with engineered strain. <i>Science</i> , 2018, 359, 1131-1136.	6.0	247
25	Strain distributions and their influence on electronic structures of WSe ₂ /MoS ₂ laterally strained heterojunctions. <i>Nature Nanotechnology</i> , 2018, 13, 152-158.	15.6	206
26	Graphene-based bimorphs for micron-sized, autonomous origami machines. <i>Proceedings of the National Academy of Sciences of the United States of America</i> , 2018, 115, 466-470.	3.3	144
27	Sub-nanometre channels embedded in two-dimensional materials. <i>Nature Materials</i> , 2018, 17, 129-133.	13.3	97
28	Real-space Demonstration of 0.4 Angstrom Resolution at 80 keV via Electron Ptychography with a High Dynamic Range Pixel Array Detector. <i>Microscopy and Microanalysis</i> , 2018, 24, 194-195.	0.2	0
29	AirSEM: Electron Microscopy in Air, without a Specimen Chamber. <i>Microscopy and Microanalysis</i> , 2018, 24, 342-343.	0.2	0
30	Mapping Strain and Relaxation in 2D Heterojunctions with Sub-picometer Precision. <i>Microscopy and Microanalysis</i> , 2018, 24, 1588-1589.	0.2	0
31	Mechanism of Gold-Assisted Exfoliation of Centimeter-Sized Transition-Metal Dichalcogenide Monolayers. <i>ACS Nano</i> , 2018, 12, 10463-10472.	7.3	203
32	In Situ-Generated Volatile Precursor for CVD Growth of a Semimetallic 2D Dichalcogenide. <i>ACS Applied Materials & Interfaces</i> , 2018, 10, 34401-34408.	4.0	23
33	Synthetic Lateral Metal-Semiconductor Heterostructures of Transition Metal Disulfides. <i>Journal of the American Chemical Society</i> , 2018, 140, 12354-12358.	6.6	85
34	Strain Mapping of Two-Dimensional Heterostructures with Subpicometer Precision. <i>Nano Letters</i> , 2018, 18, 3746-3751.	4.5	82
35	Intrinsic Two-Dimensional Ferroelectricity with Dipole Locking. <i>Physical Review Letters</i> , 2018, 120, 227601.	2.9	322
36	Theory and practice of electron diffraction from single atoms and extended objects using an EMPAD. <i>Microscopy (Oxford, England)</i> , 2018, 67, i150-i161.	0.7	29

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37	Electron ptychography of 2D materials to deep sub-Ångström resolution. <i>Nature</i> , 2018, 559, 343-349.	13.7	431
38	Characterization of Sulfur and Nanostructured Sulfur Battery Cathodes in Electron Microscopy Without Sublimation Artifacts. <i>Microscopy and Microanalysis</i> , 2017, 23, 155-162.	0.2	40
39	Janus monolayers of transition metal dichalcogenides. <i>Nature Nanotechnology</i> , 2017, 12, 744-749.	15.6	1,459
40	Photoconductivity: Tailoring Semiconductor Lateral Multijunctions for Giant Photoconductivity Enhancement (<i>Adv. Mater.</i> 41/2017). <i>Advanced Materials</i> , 2017, 29, .	11.1	0
41	Theory and Practice of Diffractometry on Single Tungsten Atoms using Electron Microscope Pixel Array Detectors. <i>Microscopy and Microanalysis</i> , 2017, 23, 444-445.	0.2	2
42	Layer-by-layer assembly of two-dimensional materials into wafer-scale heterostructures. <i>Nature</i> , 2017, 550, 229-233.	13.7	442
43	Tailoring Semiconductor Lateral Multijunctions for Giant Photoconductivity Enhancement. <i>Advanced Materials</i> , 2017, 29, 1703680.	11.1	21
44	Chemical Vapor Deposition Growth of Large Single-Crystal Mono-, Bi-, Tri-Layer Hexagonal Boron Nitride and Their Interlayer Stacking. <i>ACS Nano</i> , 2017, 11, 12057-12066.	7.3	85
45	Picometer-Precision Strain Mapping of Two-Dimensional Heterostructures using an Electron Microscope Pixel Array Detector (EMPAD). <i>Microscopy and Microanalysis</i> , 2017, 23, 1712-1713.	0.2	1
46	Breaking Friedel's Law in Polar Two Dimensional Materials. <i>Microscopy and Microanalysis</i> , 2017, 23, 1738-1739.	0.2	1
47	Enhanced Resolution from Full-Field Ptychography with an Electron Microscope Pixel Array Detector. <i>Microscopy and Microanalysis</i> , 2017, 23, 438-439.	0.2	0
48	Strain Accommodation and Coherency in Laterally-Stitched WSe ₂ /WS ₂ Junctions. <i>Microscopy and Microanalysis</i> , 2016, 22, 870-871.	0.2	5
49	Large-scale chemical assembly of atomically thin transistors and circuits. <i>Nature Nanotechnology</i> , 2016, 11, 954-959.	15.6	251
50	Graphene Oxide Nanosheets Stimulate Ruffling and Shedding of Mammalian Cell Plasma Membranes. <i>CheM</i> , 2016, 1, 273-286.	5.8	30
51	Atomically Thin Graphene Windows That Enable High Contrast Electron Microscopy without a Specimen Vacuum Chamber. <i>Nano Letters</i> , 2016, 16, 7427-7432.	4.5	13
52	Electron Diffraction from a Single Atom and Optimal Signal Detection. <i>Microscopy and Microanalysis</i> , 2016, 22, 846-847.	0.2	3
53	Atomically Thin Ohmic Edge Contacts Between Two-Dimensional Materials. <i>ACS Nano</i> , 2016, 10, 6392-6399.	7.3	202
54	Electron Microscopy in Air: Transparent Atomic Membranes and Imaging Modes. <i>Microscopy and Microanalysis</i> , 2015, 21, 1111-1112.	0.2	5

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55	High-mobility three-atom-thick semiconducting films with wafer-scale homogeneity. <i>Nature</i> , 2015, 520, 656-660.	13.7	1,562
56	Esaki Diodes in van der Waals Heterojunctions with Broken-Gap Energy Band Alignment. <i>Nano Letters</i> , 2015, 15, 5791-5798.	4.5	319